

Receipt #6
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Atty. Dkt No
33082M110

ATTN: OFFICE OF INITIAL PATENT EXAMINATION'S CUSTOMER SERVICE CENTER
PATENT
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yoshihito OOKAWA et al.

Serial No.: 09/980,309

Group Art Unit: 1734

Filed: November 30, 2001

Examiner: To Be Assigned

For : PLASMA PROCESSING UNIT, WINDOW MEMBER FOR PLASMA
PROCESSING UNIT AND ELECTRODE PLATE FOR PLASMA
PROCESSING UNIT

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

ATTN: OFFICE OF INITIAL PATENT EXAMINATION'S
CUSTOMER SERVICE CENTER
Assistant Commissioner for Patents
Washington, D.C. 20231

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Sir:

A marked-up copy of the Official Filing Receipt in the above-referenced application is attached. It is respectfully requested that a corrected Official Filing Receipt be issued with the following corrections:

1. please change second inventor's residence to **-Yamanashi-ken, JAPAN--**; and
2. please change the title to **-- PLASMA PROCESSING UNIT, WINDOW MEMBER FOR PLASMA PROCESSING UNIT AND ELECTRODE PLATE FOR PLASMA PROCESSING UNIT--**.



Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP

By:
Michael A. Makuch, Reg. No. 32,263
1850 M Street, N.W., Suite 800
Washington, D.C. 20036
Telephone: (202) 659-2811
Facsimile: (202) 263-4329

February 5, 2002

MAM



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/980,309	11/30/2001	1734	890	33082M110	2	12	2

CONFIRMATION NO. 9768

00441

SMITH, GAMBRELL & RUSSELL, LLP
1850 M STREET, N.W., SUITE 800
WASHINGTON, DC 20036

FILING RECEIPT



OC000000007336637

Date Mailed: 01/22/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Yoshihito Ookawa, Kofu-Shi, JAPAN;
Daisuke Hayashi, ~~Ryuo-Cho~~, JAPAN;
Yamanashi-ken, JAPAN

Domestic Priority data as claimed by applicant

THIS APPLICATION IS A 371 OF PCT/JP00/03543 06/01/2000

Foreign Applications

JAPAN 11-155539 06/02/1999

Projected Publication Date: Not Applicable, filed prior to November 29, 2000

Non-Publication Request: No

Early Publication Request: No

Title

unit
Plasma processing device, window member for the plasma processing device and electrode plate
for the plasma processing device unit

Preliminary Class

118

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